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Patent Attorney Docket No. 81329A

TRANSMITTAL LETTER

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TC 2800 MAIL ROOM

Inventor: Joseph J. Danko

Examiner:

Serial No: 09/579,593

Filed: May 26, 2000

For: METHOD AND APPARATUS FOR INSPECTING A PATTERNED SEMICONDUCTOR WAFER

Batch No:

Group Art Unit: 2877

Assistant Commissioner for Patents  
Washington, D. C. 20231

Dear Sir:

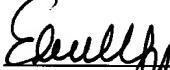
Transmitted herewith for the above-identified patent application are the following:

A Change of Attorney's Address in Application  
A return postcard

The item(s) checked below are appropriate:

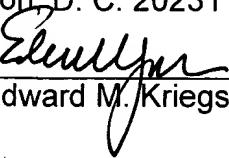
1.  Applicant(s) hereby petition(s) for a ( ) month extension of time to respond to
  
2.  Please charge any fees or costs not accounted for to Deposit Account No. 11-1755.

Date: May 24, 2001

  
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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D. C. 20231 on May 29, 2001

  
Edward M. Kriegsman